

**IN THE UNITED STATES  
PATENT AND TRADEMARK OFFICE**

PATENT

Applicants:	<b>Yoshitaka Nishio, et al.</b>	Atty. Docket No.:	<b>49288.3500</b>
Serial No.:	<b>10/598,878</b>	Examiner	<b>Ghassem Alie</b>
Date Filed:	<b>May 21, 2007</b>	Group Art Unit:	<b>3724</b>
Title:	<b>SUBSTRATE DIVIDING SYSTEM, SUBSTRATE MANUFACTURING EQUIPMENT, SUBSTRATE SCRIBING METHOD AND SUBSTRATE DIVIDING METHOD</b>	Confirmation No.:	<b>1712</b>

**AMENDMENT AND REPLY**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Commissioner:

In reply to the Office Action mailed on February 19, 2010, of which this Reply is filed within the two month shortened statutory period for reply, please consider the following amendments and remarks:

**Amendments to the Abstract** begins on page 2.

**Amendments to the Drawing** begins on page 3.

**Amendments to the Claims** are reflected in the listing of claims, which begins on page 4 of this paper.

**Remarks** begin on page 10 of this paper.